



Docket No.: 065933-0084

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277  
Ryosuke USUI, et al. : Confirmation Number: 3812  
Application No.: 10/813,629 : Group Art Unit: 2814  
Filed: March 31, 2004 : Examiner: Dilinh P. Nguyen  
For: SEMICONDUCTOR MODULE AND METHOD OF MANUFACTURING THE SAME

CORRECTED INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

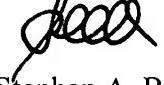
This corrected Information Disclosure Statement is being filed after the filing of the application in order to correct a typographical error in the listing of the Japanese Office Action issued in corresponding Japanese Patent Application No. 2004-086770. **Japanese Patent Application No. 2004-086770** was erroneously listed as **Japanese Patent Application No. 2004-086770** in an Information Disclosure Statement filed on **February 28, 2007**. The reference is correctly listed on the attached form PTO-1449 as Japanese Patent Application No. 2004-086770.

**10/813,629**

Please charge any shortage in fees due in connection with the filing of this paper,  
including extension of time fees, to Deposit Account 500417 and please credit any excess fees to  
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Respectfully submitted,

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**Date: March 28, 2007**

**Please recognize our Customer No. 20277  
as our correspondence address.**



SHEET 1 OF 1

# INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(PTO-1449)

ATTY. DOCKET NO  
**065933-0084**

SERIAL NO.  
**10/813,629**

**APPLICANT**  
**Ryosuke USUI, et al.**

**FILING DATE**  
**March 31, 2004**

## U.S. PATENT DOCUMENTS

## FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number + Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation Yes	Translation No
		JP 2001-274293 A	10-05-2001	HITACHI CHEM CO LTD		JAPAN (w/English Abstract)	

OTHER ART (Including Author Title Date Pertinent Pages Etc)

CITATIONARY (including Author, Title, Date, Publication, Page(s), Etc.)		
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
		Japanese Office Action issued in corresponding Japanese Patent Application No. 2004-086770, dated November 28, 2006
EXAMINER		DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.